## IN THE UNITED STATES PATENT AND TRADE ARK OFFICE Apphicant(s): Ogawa fial No.: 09/964,995 Group Art Unit: 2811 Filed: September 27, 2001 Examiner: Tran, Thien F. Semiconductor Title: Device and Manufacturing Method Therefor Attorney Docket No.: N29748500S RESPONSE TO OFFICE ACTION **Assistant Commissioner for Patents** Washington, D.C. 20231 Dear Sir: The following is submitted in response to the Office Action dated February 20, 2002, and is currently due March 20, 2002. **REMARKS Election without Traverse** In response to the restriction requirement set forth in the Office Action dated January 8, 2002, the claims of Group I (claims 1-11) are elected without traverse. Respectfully Submitted, Darryl G. Walker Attorney Reg. No. 43,232 Darryl G. Walker WALKER & SAKO, LLP 300 South First Street Suite 235 San Jose, CA 95113 Tel. 1-408-289-5314

37 C.F.R. §1.8

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to:
Assistant Commissioner for Patents, Washington, D.C. 20231.

Date of Deposit: \_\_March 18, 2002\_\_\_\_\_\_

Typed Name: Darryl G. Walker

Typed Name: Darryl G. Warker

Signature: